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PATENTS

Attorney Docket No.: ELM-2 CONT.4

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Glenn J. Leedy  
Application No. : 10/672,961 Confirmation No.: 9439  
Filed : September 26, 2003  
For : THREE DIMENSIONAL STRUCTURE INTEGRATED  
CIRCUIT  
Group Art Unit : 2822  
Examiner : Monica Lewis

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

In accordance with 37 C.F.R. §§ 1.56 and 1.97,  
applicant wishes to call the attention of the Examiner to the  
following documents:

U.S. Patents		
Lischke	4,724,328	02/09/88
Bergmans et al.	4,835,765	05/30/89
Mauger et al.	4,919,749	04/24/90
Benecke et al.	4,994,336	02/19/91
Fueki et al.	5,144,142	11/16/93
Fueki et al.	5,262,341	11/16/93
Hashiguchi et al.	5,358,909	10/25/94
Enomoto et al.	5,514,628	05/07/96
Chen et al.	5,620,915	04/15/97
Leedy	5,637,907	06/10/97

Brandes et al.	6,445,006	09/03/02
Leedy	6,682,981	01/27/04
Leedy	6,713,327	03/30/04
Leedy	6,714,625	03/30/04
Leedy	6,765,279	07/20/04
Leedy	6,838,896	01/04/05
Leedy	6,891,387	05/10/05
Leedy	2003/0223535	12/04/03
Leedy	2003/0218182	11/27/03

#### Foreign Patents

Kouno	GB 2,125,168	02/29/84
Komatsu Ltd.	JP S63-076484	04/06/88
Benecke et al.	JP 02-037655	02/07/90
Canon Inc.	JP 03-127816	05/30/91
Fujitsu Ltd.	JP 03-174715	07/29/91
Canon Kabushiki	EP 0 518 283	12/16/92
Chalmers Technology	WO 03/078305	09/25/03

#### Other Documents

"Christensens Physics of Diagnostic Radiology," Curry et al., pp.29-33, 1990.
Sung, et al., "Well-aligned carbon nitride nanotubes synthesized in anodic alumina by electron cyclotron resonance chemical vapor deposition," Applied Physics Letters, Volume 74, Number 2, 197, 1999, January 11, 1999
Phys. Rev., B., Condens. Matter Mater. Phys. (USA), Physical Review B (Condensed Matter and Materials Physics), 15 March 2003, APS through AIP, USA

These documents are listed on the accompanying Form PTO-SB/08A (submitted in duplicate), and pursuant to 37 C.F.R. § 1.98(a)(2), copies of the non-U.S. Patent documents are enclosed herewith.

Applicant reserves the right to establish the patentability of the claimed invention over any of the information provided herewith, and/or to prove that this information may not be prior art, and/or to prove that this information may not be enabling for the teachings purportedly offered.

It is respectfully requested that these references be: (1) fully considered by the Patent and Trademark Office during the examination of this application; and (2) printed on any patent which may issue on this application. Applicant requests that a copy of Form PTO-SB/08A, as considered and initialed by the Examiner, be returned with the next communication.

This Statement is being submitted before the mailing date of the first Office Action on the merits. Pursuant to 37 C.F.R. § 1.97(b)(3), submission of this Supplemental Information Disclosure Statement requires no fee. However, if for any reason a fee is due, the Director is hereby authorized to charge payment of any fees required in connection with this Statement, or credit any overpayment of the same, to Deposit Account No. 06-1075 (order no.: 001202.0127). A duplicate copy of this Supplemental Information Disclosure Statement is enclosed herewith.

An early and favorable action is respectfully  
requested.

Respectfully submitted,

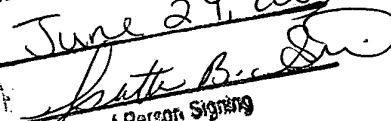


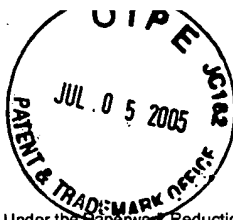
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PTO/SB/08A (10-01)

Approved for use through 10/31/2002. OMB 0651-0031

U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE

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Substitute for form 1449/PTO			<b>Complete if known</b>		
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (use as many sheets as necessary)			<b>Application Number</b>	10/672,961 (Conf. No.: 9439)	
			<b>Filing Date</b>	September 26, 2003	
			<b>First Named Inventor</b>	Glenn J. Leedy	
			<b>Art Unit</b>	2822	
			<b>Examiner Name</b>	Monica Lewis	
<b>Sheet</b>	1	<b>of</b>	2	<b>Attorney Docket Number</b>	ELM-2 Cont.4

U.S. PATENT DOCUMENTS					
Examiner initials*	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Documents	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code <sup>2</sup> (if known)			
		4,724,328	02/09/88	Lischke	
		4,835,765	05/30/89	Bergmans et al.	
		4,919,749	04/24/90	Mauger et al.	
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		Country Code <sup>1</sup> - Number <sup>2</sup> - Kind Code <sup>3</sup>				
		GB 2,125,168	02/29/84	Kouno		
		JP S63-076484	04/06/88	Komatsu Ltd.		
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		EP 0 518 283	12/16/92	Canon Kabushiki		
		WO 03/078305	09/25/03	Chalmers Technology		

\* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> See Kinds Codes of USPTO Patent Documents at [www.uspto.gov](http://www.uspto.gov) or MPEP 901.04. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language translation is attached.

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<b>Sheet</b>	2	<b>of</b>	2	<b>Attorney Docket Number</b>	ELM-2 Cont.4

NON PATENT LITERATURE DOCUMENTS			
Examiner initials	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T <sup>6</sup>
		"Christensens Physics of Diagnostic Radiology," Curry et al., pp.29-33, 1990.	
		Sung, et al., "Well-aligned carbon nitride nanotubes synthesized in anodic alumina by electron cyclotron resonance chemical vapor deposition," Applied Physics Letters, Volume 74, Number 2, 197, 1999, January 11, 1999	
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<b>Examiner Signature</b>		<b>Date Considered</b>	
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All References Have Been Considered: \_\_\_\_\_  
 Examiner